

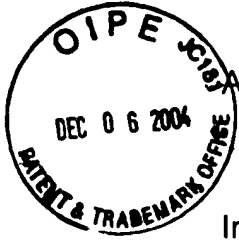
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TRANSMITTAL FORM (to be used for all correspondence after initial filing)		Application No.	10/816,234
		Filing Date	March 31, 2004
		First Named Inventor	Daoqiang Lu
		Art Unit	2812
		Examiner Name	Not Yet Assigned
Total Number of Pages in This Submission	10	Attorney Docket Number	42P19140

ENCLOSURES (check all that apply)		
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Attorney's Docket No. 042390.P19140

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:)

Daoqiang Lu, et al)

Application No: 10/816,234)

Filed: March 31, 2004)

For: Wafer Support And Release In)
Wafer Processing)

Examiner: Not Yet Assigned

Art Unit: 2812

Commissioner for Patents
P.O. Box 1450
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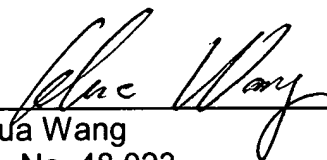
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If there are any additional charges, please charge Deposit Account No. 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Dated: 12/1, 2004



Lehua Wang
Reg. No. 48,023

12400 Wilshire Blvd.
Seventh Floor
Los Angeles, CA 90025
(408) 720-8300



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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

Sheet 1 of 1

Complete if Known

Application Number	10/816,234
Filing Date	March 31, 2004
First Named Inventor	Daoqiang Lu
Art Unit	2812
Examiner Name	Not Yet Assigned
Attorney Docket Number	42P19140

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
		AI TECHNOLOGY, Dicing and Lapping Tapes for Wafer and Substrate. Product-line Overview. Copyright 2001 A.I. Technology, Inc. Last modified 9/18/2001. Pages 1-2.	
		ASI ADHESIVES & SEALANTS INDUSTRY, UV/EB-Curable Acrylate Silicones for Release Coatings. Posted on 5/29/2002. Pages 1-6.	
		Lamination Process UV Release Films. Lamination Process for UV Releasing Dicing Tape to Wafer-Substrate. Page 1-2.	
		POLYMER BULLETIN, Concentration effects of methylalumoxane, palladium and nickel pre-catalyst and monomer in the vinyl polymerization of norbornene by Christoph Janiak and Paul-Gerhard Lassahn. 2/27/2001.	
		IZM, New Process Scheme for Wafer Thinning and Stress-free Separation of Ultra Thin ICs by C. Landesberger, et al. Microsystems Technologies 2001. pp. 431-436.	
		INSTITUTE OF PHYSICS PUBLISHING, Sacrificial polymers for nanofluidic channels in biological applications by Wanli Li, et al. Published 4/14/2003.	

Examiner Signature	Date Considered
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Based on PTO/SB/08B (08-03) as modified by Blakely, Solokoff, Taylor & Zafman (wlr) 08/11/2003.
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